APPLICATION DATA SHEET UNDER 37 C.F.R. §1.76

Inventor Information

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Application Information

Title: METHOD OF EPITAXY ON A SILICON SUBSTRATE COMPRISING AREAS HEAVILY DOPED WITH ARSENIC

Total Drawing Sheets: Formal Drawings?

Yes

Application Type: N

Non-Provisional Utility

Art Unit: Unknown
Docket Number: \$1022/8562

Representative Information

Representative Customer Number:: 23628

Continuity Information

This application is a:

Non-provisional

Claiming priority to:

Non-Provisional application docket nos. S1022/8562 and S1022/8072

Serial Number: Filing Date: Not yet assigned July 10, 2001

Status: Pending

Prior Foreign Applications

Foreign Application Number: Filing Date:

97/10032 July 31, 1997

Country: Priority Claimed: France Yes

Assignee Information (when available)

Name of Assignee:

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